

FORM PTO-1449 U.S. DEPARTMENT OF COMMERCE  
(Modified) PATENT AND TRADEMARK OFFICE  
INFORMATION DISCLOSURE  
STATEMENT BY APPLICANT  
(37 CFR 1.98(b)) Page 1 of 2

ATTY. DOCKET NO. USA.342-1	SERIAL NO. To be determined 10/791,079
APPLICANT Brad Geving et al.	
FILING DATE March 2, 2004	GROUP To be determined 1742

**U.S. PATENT DOCUMENTS**

EXAMINER INITIAL	PATENT NUMBER	ISSUE DATE	PATENTEE	CLASS	SUB-CLASS	FILING DATE
n.m	4,247,508	01/27/81	Housholder			
	4,327,156	04/27/82	Dillon et al.			
	4,554,218	11/19/85	Gardner et al.			
	4,863,538	09/05/89	Deckard			
	4,944,817	07/31/90	Bourell et al.			
	5,017,753	05/21/91	Deckard			
	5,076,869	12/31/91	Bourell et al.			
	5,296,062	03/22/94	Bourell et al.			
	5,340,656	08/23/94	Sachs et al.			
	5,387,380	02/07/95	Cima et al.			
	5,433,280	07/18/95	Smith			
	5,544,550	08/13/96	Smith			
	5,749,041	05/05/98	Lakshminarayan et al.			
n.m	5,839,329	11/24/98	Smith et al.			

**FOREIGN PATENT OR PUBLISHED FOREIGN PATENT APPLICATION**

		DOCUMENT NUMBER	PUB. DATE	COUNTRY OR PATENT OFFICE	CLASS	SUB-CLASS	Translation YES NO
							1
							1

**OTHER DOCUMENTS (Including Author, Title, Date\*\*, Relevant Pages, Place of Publication\*\*\*)**

n.m			Stein, G. et al., "Current and Future Applications of High Nitrogen Steels," <u>Materials Science Forum, Vols. 318-320 (1999)</u> , pp. 151-160.

EXAMINER

*N. Gorlan Khan*

DATE CONSIDERED

*11/23/04*

EXAMINER: Initial citation considered. Draw line through citation if not in conformance and not considered.  
Include copy of this form with next communication to applicant.

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		<b>APPLICANT</b> <b>Brad Geving et al.</b>	
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